



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Syed S. Ahmad

**Serial No.:** 09/943,967

**Filed:** August 30, 2001

**For:** APPARATUS AND METHOD FOR  
CONTROLLING THE DEPTH OF  
IMMERSION OF A SEMICONDUCTOR  
ELEMENT IN AN EXPOSED SURFACE  
OF A VISCOUS FLUID

**Examiner:** Unknown

**Group Art Unit:** 1734

**Attorney Docket No.:** 3428.2US (97-828.2)

**CERTIFICATE OF MAILING**

I hereby certify that this paper or fee along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail (under 37 C.F.R. § 1.8(a)) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

October 2, 2001  
Date of Deposit

*Debra L. Mitchell*  
Signature of registered practitioner or other  
person having reasonable basis to expect mailing  
to occur on date of deposit shown pursuant to 37  
C.F.R. § 1.8(a)(1)(ii)

Debra L. Mitchell  
Typed/printed name of person whose signature is  
contained above

**REQUEST FOR CORRECTED FILING RECEIPT**

Application Processing Division  
Customer Correction Branch  
Commissioner for Patents  
Washington, D.C. 20231

Sir:

Attached is a copy of the official filing receipt received from the PTO in the above application. Issuance of a corrected filing receipt in accordance with the annotations on the attached filing receipt copy is respectfully requested.

The errors to be corrected are as follows:

Under Total Claims, please change "87" to --89--.

Serial No. 09/943,967

These corrections are not due to any errors by applicant and no fee is due.

Respectfully submitted,



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Date: October 2, 2001

KWP/dlm

Enclosure: Copy of Official Filing Receipt with annotations correcting errors

N:\2269\3428.2\Request for Corr Filing Receipt.wpd



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
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WASHINGTON, D.C. 20231  
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/943,967	08/30/2001	1734	1916	3428.2US (97-828.2)	21	87 89	2

24247  
TRASK BRITT  
P.O. BOX 2550  
SALT LAKE CITY, UT 84110

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CONFIRMATION NO. 2663

## FILING RECEIPT



\*OC00000006813093\*

Date Mailed: 09/28/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Syed Sajid Ahmad, Boise, ID;

## Domestic Priority data as claimed by applicant

THIS APPLICATION IS A CON OF 09/183,233 10/29/1998  
WHICH IS A DIV OF 09/020,197 02/06/1998 PAT 6,040,205  
WHICH IS A CIP OF 08/906,578 08/05/1997  
AND A CIP OF 08/906,673 08/05/1997 PAT 6,013,535

## Foreign Applications

If Required, Foreign Filing License Granted 09/28/2001

Projected Publication Date: 01/10/2002

Non-Publication Request: No

Early Publication Request: No

## Title

Apparatus and method for controlling the depth of immersion of a semiconductor element in an exposed surface of a viscous fluid

Preliminary Class